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JC551 U.S. PTO
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01/20/99

Inventor: Weimin Li et al.

Title: Semiconductor Processing Methods

Assignee: Micron Technology, Inc.

INFORMATION DISCLOSURE STATEMENT

The Examiner's attention is directed to the references listed on the attached Form PTO-1449 and copies of which are attached.

Citation of these patents are respectfully requested.

Respectfully submitted,

Date:

1/20/99

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Date:

Jan 14, 1999

Inventor:

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Date:

1-8-99

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